Electronic Acknowledgement Receipt FES ID: 1236279 Application Number: 10628001 Confirmation Number: 3943 METHOD FOR AUTOMATIC DETERMINATION OF Title of Invention: SEMICONDUCTOR PLASMA CHAMBER MATCHING AND SOURCE OF FAULT BY COMPREHENSIVE PLASMA MONITORING First Named Inventor: Matthew F. Davis Customer Number: 44182 Filer: Robert W. Mulcahy/Sheri Griffin Filer Authorized By: Robert W. Mulcahy Attorney Docket Number: AMAT/7938/ETCH/SILICON/JB Receipt Date: 04-OCT-2006 Filing Date: 25-JUL-2003 Time Stamp: 18:36:47 Application Type: Utility International Application Number:

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